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Structural, Morphological, Optical and PL Studies of Neodymium Doped ZnS Glass Plate by Nebulizer Spray Pyrolysis Method

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Abstract— Herein we have present the preparation of Nd doped ZnS thin films on glass substrate by simple nebulizer spray pyrolysis (NSP) method at 450 ^oC. XRD, SEM, and UV-Vis Spectrometer were used to analyze the Structural, morphological, and optical behavior of the prepared samples. Nature of polycrystalline hexagonal structure with no secondary phases was confirmed by X-ray analysis. Extra particle creation on the surface of the Nd doped thin film was observed in high magnified SEM images. Room temperature PL studies depicts that the luminance behavior of the parent sample was enormously changed during the Nd element interstitial with ZnS lattice. Optical band gap value varies from 3.51 eV to 3.58 eV for 3% Nd doped ZnS film ascribed the increasing of film thickness and diminishing of film transparencies.

Keywords—Rare earth, Thin film, Nebulizer spray pyrolysis, Photoluminescence, Band gap.

I. INTRODUCTION

Naturally, II-VI based semiconductor with wide direct band gap (Eg=3.67 eV) of ZnS has Luminescence behavior and it is used as a photo catalyst for a long time. Besides the contribution of CdS, toxic free ZnS have many Opto electronic applications such as , UV light emitting diodes, sensors, Modulators [1] etc., In addition, it act as a good reflector and dielectric filter [2]. Meanwhile, additions of transition or rare earth metal in ZnS were arising new kinds of pictures in luminescence recently. Even though, there are many reports available on transition metal doped like Mn, Cu, Al, Pb etc., and their co-doped ZnS thin film, only countable numbers of papers behind on rare earth metal doping. The main reason regarding on this lack may be expensive and unavailability of rare earth material. At the same time we should concern their unique behavior when doped with any host lattice. Because, some trivalent rare earth ions change vigorously in parent lattice structure and their optical behavior than transition metal. So, herein we synthesized rare earth Nd doped ZnS film and characterized their behavior using various parameters.

Core ZnS thin film was prepared by various techniques such as SILAR [3], Sputtering [4], Electro deposition [5], ALE [6], CBD [7], CVD [8] spray pyrolysis [9] etc., Apart from these, herein we tried to attempt on making homogeneous transparent thin film by simplest NSP techniques.NSP is a kind of Spray technique and it is low cost and more suitable for large scale thin film preparation.

II. MATERIALS AND METHODS

Thin films of host and Nd doped ZnS were prepared with analytical grade Zinc chloride [ZnCl₂], Thiourea [CH₄N₂S] and Neodymium acetate monohydrate [Nd(CH₃COO)₂.H₂O] (purchased from Sigma-Aldrich and Alfa Aeser) by NSP technique. To remove any impurities, glass substrates were cleaned by hot chromic acid, de-ionized water, and acetone. For a parent precursor solution 0.2 M (ZnCl₂) and 0.2 M (CH₄N₂S) were dissolved into 10 ml (Isopropyl alcohol and de-ionized water with 3:1 ratio) solvent and stirred well for 10 min. To make 3 % Nd doped film, neodymium acetate monohydrate [Nd (CH₃COO)₂.H₂O] was dissolved in the prepared parent solution and adding of three drops of HCl make clear homogeneous solution. These solutions were taken in a nebulizer container of volume 10 ml and sprayed with Carrier gas pressure of 1.5 Kg/cm² on the heated(450 °C) glass substrate (located at 25mm from the nozzle) continuously to get a uniformly smooth film.

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The Structural properties studied by XPERT SOFTWAR using CuK α (λ =1.5406 nm) radiation. Morphological view of the film was assessed by SEM (Hitachi S-3000H). Transmission and band gap values were analyzed by Shimadzu (UV-3101PC) spectrophotometer. Stylus profile meter (Mitutoyo SJ-301) was used to find the thickness of the Nd:ZnS films. Photoluminescence (PL) were recorded using Perkin Elmer LS55 florescent spectrophotometer.

III. RESULTS AND DISCUSSION

XRD Analysis

Fig.1 shows the XRD patterns of Nd:ZnS thin films. Obtained films have polycrystalline hexahonal structure and matched with JCPDS file No:89-2739.In addition, they have no any other secondary peaks due to neodymium or neodymium oxide when rare earth element was doped with host lattice. From the XRD, it clearly reveals that the high intense peak of pure ZnS is orient along the (102) plane and there is some low intense peak present along (101), (103), (108), (109) and (116) planes. However, when Nd element doped with host ZnS, intensity of the reflection peaks decreases, indicates that decressing of crystaline size or incresing of crystal lattice imperfection owing to the higher ionic radius of Nd^{3+} (0.98Å) was not perfectly fit with host Z nS lattice of low ionic radius Zn^{2+} (0.74 Å). These results were matched with previous report [10] for Al doped ZnS thin films and confirmed in our SEM image.Moreover, the cystalline size calculated by debye scherer formula [11].

$$D = \frac{0.9\lambda}{\beta\cos\theta}$$

and crystal imperfections such as dislocation density (δ) and micro strain (ϵ) calculated with Williamson and tangent relations [11].

$$\varepsilon = \frac{\beta \cos \theta}{4}$$
(2)
$$\delta = \frac{1}{D^2}$$
(3)

(1)

from our XRD data Confirmed the same results.

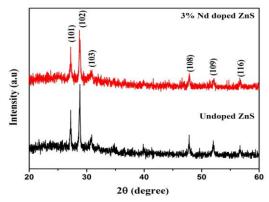


Figure 1. XRD patterns of Undoped and 3% Nd doped ZnS thin film In addition, we have calculated the lattice parameters 'a' and 'c' of the films by the following relations [12].

$$\frac{1}{d^2} = \frac{4}{3} \left\{ \frac{h^2 + hk + k^2}{a^2} \right\} + \left\{ \frac{l^2}{c^2} \right\}$$
(4)

Where, all constants have their usual meanings. The decrement of value of lattice parameters when Nd ions doped with ZnS means changing of crystal growth orientation and evidenced by our XRD intensity variation plot and same result was obtained for K.D.A. Kumar et al [13] when Nd doped with SnO₂. All structural parameters were tabulated given below.

Table 1. The structural parameters and lattice constants of prepared samples

Nd doping level (%)	Crystallite size (<i>nm</i>)	Dislocation density $(\times 10^{15})nm^{-2}$	Strain (lines ⁻ ² .m ⁻⁴)	Lattice <i>a =3.812</i>	c =18.690
0	55	0.321	0.00252	3.805	18.725
3	51	0.377	0.00271	3.778	18.692

Morphological Studies by SEM

High magnified SEM images shown surface morphology of Pure (fig 2a) and 3% Neodymium (fig 2b) doped ZnS thin films. SEM image of the undoped film visualize that they are homogeneous nature with spherical grains in nanometer range. Whereas, when Nd element was doped with parent film, it is a results of creation of extra particle accumulation on the host lattice; which ascribed the higher ionic radius of Nd³⁺ ions couldn't incorporate well to the lower ionic radius of Zn²⁺ ions in host lattice and makes some imperfection and increment of film thickness. Defects calculation made from XRD data and thickness measurement from Stylus profile meter confirms the above results.

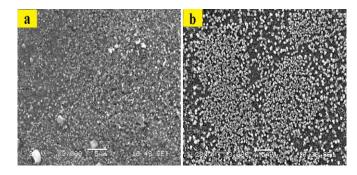


Figure 2. SEM images of a) Undoped and b) 3% Nd doped ZnS thin film

Optical Spectra

Transmittance spectra of synthesized films were portrayed in fig.3. It is seen that the transparency of film decreases when Nd element interstitial with ZnS lattice; which means that scattering of photons increment when thickness of the film increases [14] and it is confirmed by SEM images.

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Using absorption coefficient (α), Optical band gap (*Eg*) of the prepared films was determined by the Tauc's formula [12].

$$\alpha h \nu = \mathbf{B} (\mathbf{h} \nu - \mathbf{E}_{\sigma})^{n} \qquad (5)$$

Here, (hv) is the incident photon energy, and (*B*) is constant value. Pure and 3 % Nd doped ZnS film have band gap of value 3.58 and 3.62 eV and they are shown in Fig.4. The average of this band gap value is very close to the value of bulk ZnS (3.60eV) material and previous report [15].

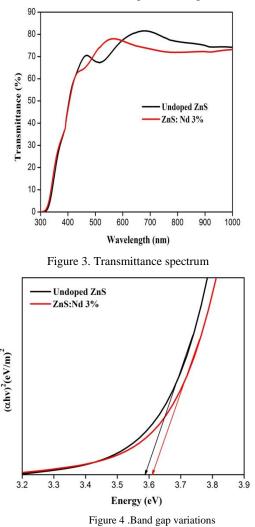


Table 2 shows the values of transparencies, thickness and band gap of the Nd:ZnS thin films.

Table 2. The value of optical transmittance, thickness and band gap of the prepared samples

Nd doping level (%)	Transmittance (%)	Thickness (nm)	Band gap (eV)
0	83	230	3.58
3	78	302	3.62

PL Spectra

Photoluminescence (PL) analysis used to determine the quality of the film and radiative transition between the conduction band and the valance band at room temperature.PL spectra of pure and Nd doped films at 325 nm excitation wavelength are displayed in fig 5. In our case, PL Spectrum shows two peaks at 395 and 460 nm. Broad UV emission peak present at 395 nm corresponds to the sulphur vacancies and the same result was reported by sabitha et al for Al:ZnS film [12]. Recombination of electron-hole pairs in zinc vacancies [16] creates high intense visible emission bands at 460 nm. In addition, when Nd element incorporate with host ZnS lattice intensity of the visible emission peak changes enormously; which ascribed the population enhancement in host lattice and easiest energy transfer between the band levels [17].

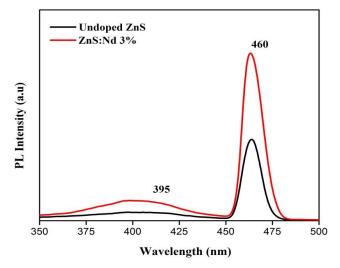


Figure 5. Room temperature PL spectrum of Undoped and 3% Nd doped ZnS thin film

IV. CONCLUSION

Pure and Nd doped ZnS thin films were prepared by low cost NSP technique. Polycrystalline with hexagonal structure of the prepared films were evidenced by XRD. Crystalline sizes, micro strain, lattice parameters of the samples were also calculated from XRD data. Particle in the shape of spherically was shown in SEM images. Band gap values of the films were determined by optical studies. High intense, blue Shift of the PL spectrum obtained from the doped film concludes that they are more suitable for creating new kind of luminescence based devices.

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